

# JCK MEMS/NEMS 2019

The 10<sup>th</sup> Japan-China-Korea  
Joint Conference on MEMS/NEMS



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Search>> [JCK 2019 MEMS Asahikawa](https://unit.aist.go.jp/umemsme/JCK2019/JCK2019_welcome.html)



**16-18 July 2019**  
**Asahikawa JAPAN**

Venue: Asahikawa Crystal Hall

[https://unit.aist.go.jp/umemsme/JCK2019/JCK2019\\_welcome.html](https://unit.aist.go.jp/umemsme/JCK2019/JCK2019_welcome.html)

**Conference Chair**

**Prof. Sang-Seok Lee, Tottori University**

Organized by Tottori University, UMEMSME/AIST

Sponsored by JCK MEMS, JSPS

Speakers from the Premier Specialists (Confirmed)

Prof. Masayoshi Esashi, Tohoku University

Prof. Chengkuo Lee, National University of Singapore

Prof. Sukhan Lee, Sungkyunkwan University

Prof. Yu-Cheng Lin, National Cheng Kung University



## Conference Scope

1. Micro & nano fabrication including 3D printing
2. Micro & nano electronics including flexible electronics
3. Micro & nano sensors & actuators
4. Micro & nano systems
5. Networked microsystems & IoT technologies
6. Materials & device characterization
7. Integration & packaging technologies
8. Modeling & simulation of manufacturing process
9. Others



Reception at Asahiyama Zoo  
Banquet at Lavender Farm

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## Important Dates !

Submission & Registration Deadline

**10<sup>th</sup> May 2019 (If you need VISA)**

**11<sup>th</sup> June 2019 (Others)**